



on April 14, 2003

Date of Deposit

Anastasia Heffner

Name of applicant, assignee or
Registered Representative

Registered Representative
Anastasia Heffner

Signature

Signature
4-14-03

Date of Signature

Our Case No. 7103/205

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Li et al.

Serial No. 09/938,056

Filing Date: August 23, 2001

For MULTI-STEP POLISHING SYSTEM
AND PROCESS OF USING SAME

Examiner: George Nguyen

Group Art Unit No.: 3723

RECEIVED

APR 23 2003

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

TECHNOLOGY CENTER R3700

Dear Sir:

In reply to the Office Action dated November 14, 2002, Applicants have filed this Amendment by Certificate of Mailing. Applicant respectfully requests the Examiner to withdraw the objections and rejections to this application and to grant allowance of this Application in view of the following remarks and amended claims: